

# Phase Plate after CRL

--A promising way to get a cleaner focus

## ARTICLE

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## Perfect X-ray focusing via fitting corrective glasses to aberrated optics

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# CSSI: coherent surface scattering imaging

- Experiment setup at PETRA III

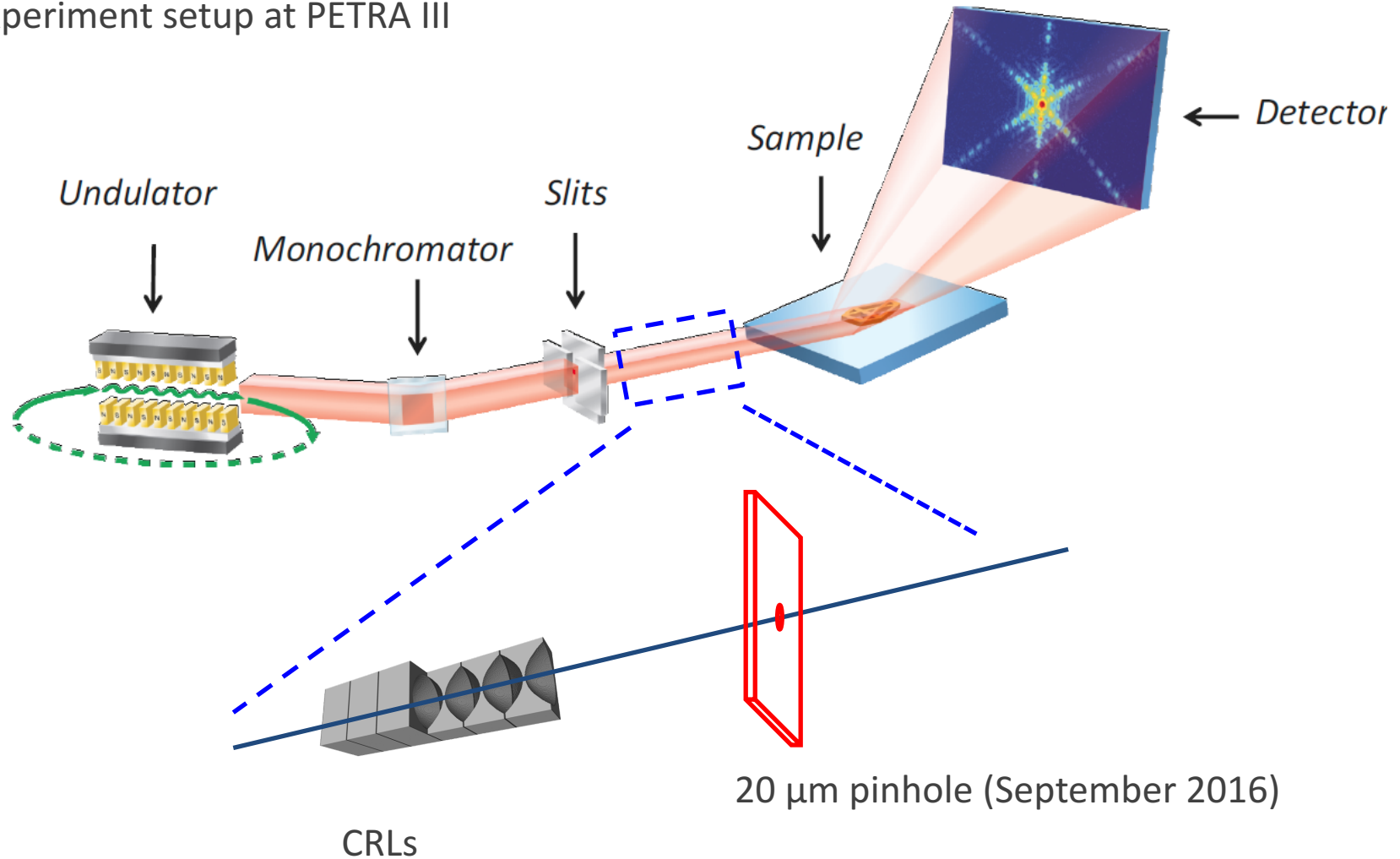


Image from Jin Wang's APS-U talk, Nov. 2016

# CSSI: coherent surface scattering imaging

- Experiment setup at PETRA III

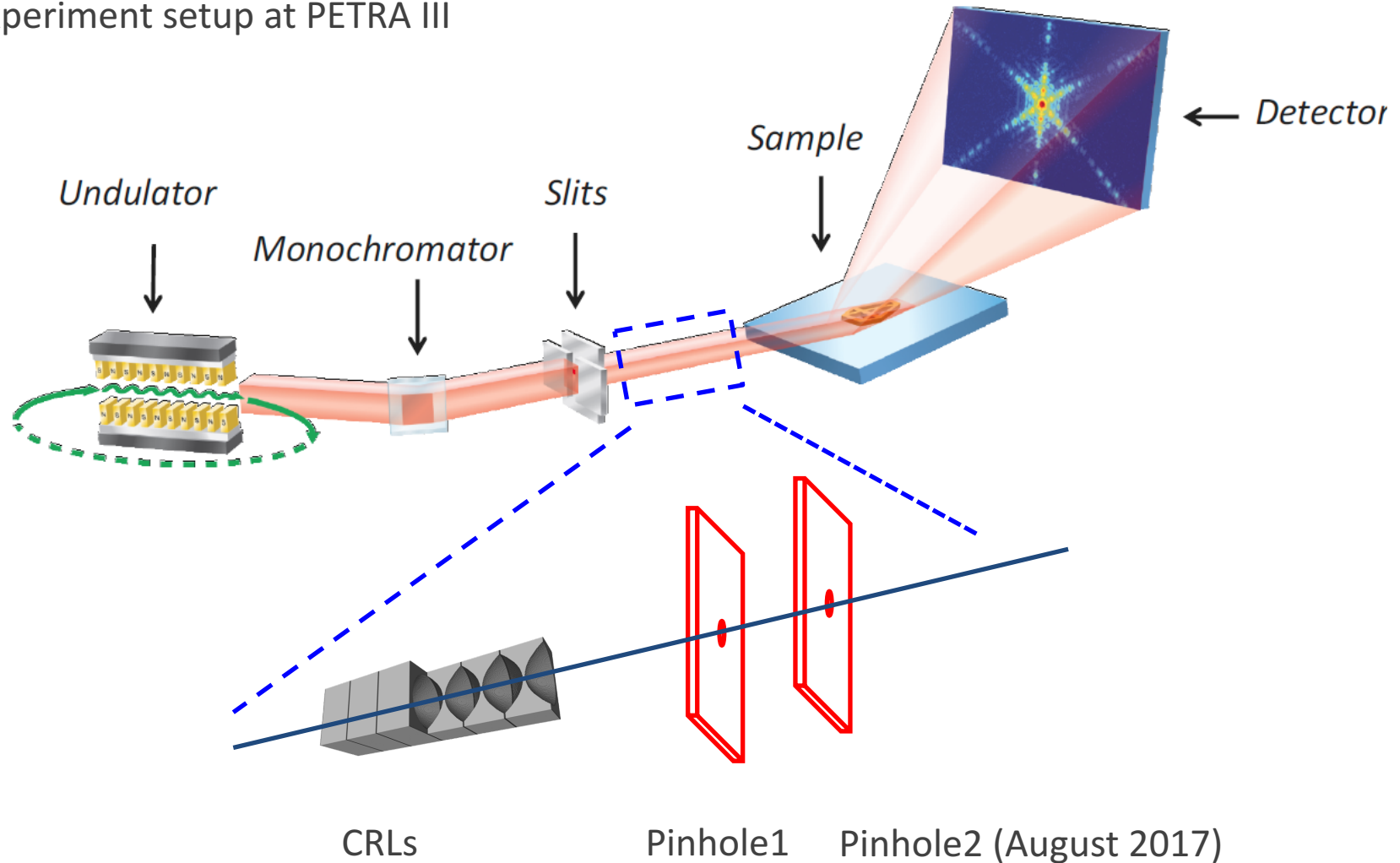
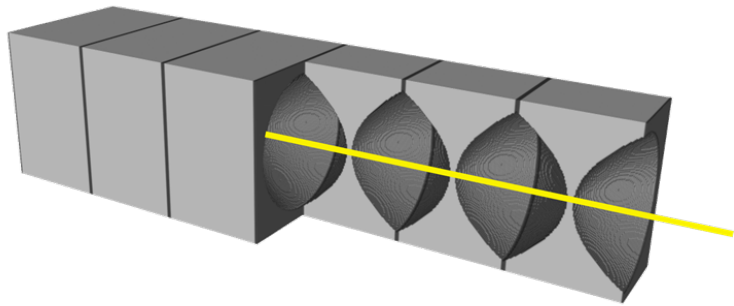
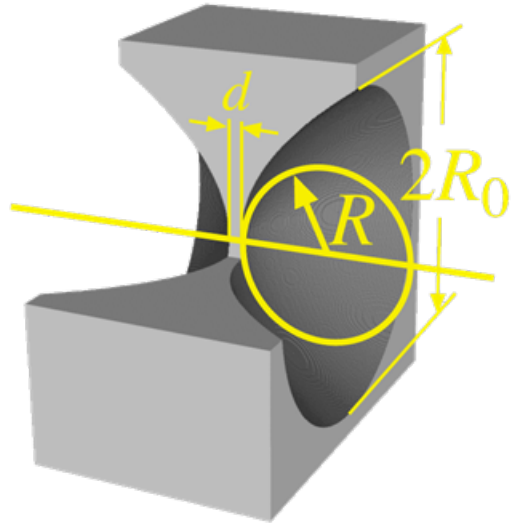


Image from Jin Wang's APS-U talk, Nov. 2016

# Compound Refractive Lens (CRLs)



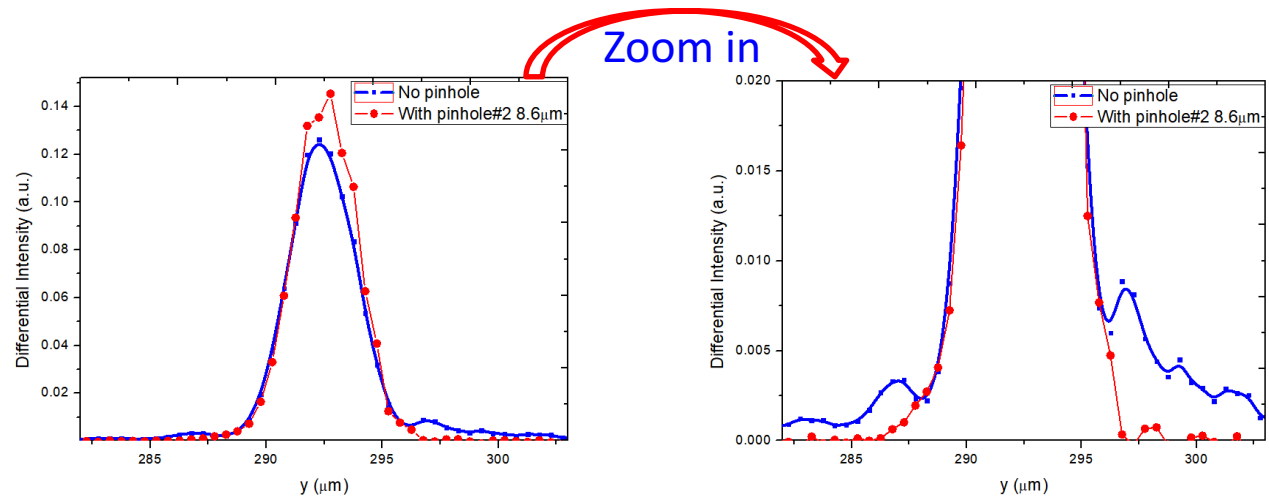
- Low z material, Be/Al/Ni
- Parabolic and biconcave profile
  - “No optical aberration”
  - Focusing in whole plane
  
- On-axis focusing element
- Compact
- High heat load
  
- Be CRLs are produced by powder metallurgy
  - Powder blending
  - Impurities, grain boundaries
  - “Precision die” compaction
  - Sintering

Small angle scattering  
Aberration

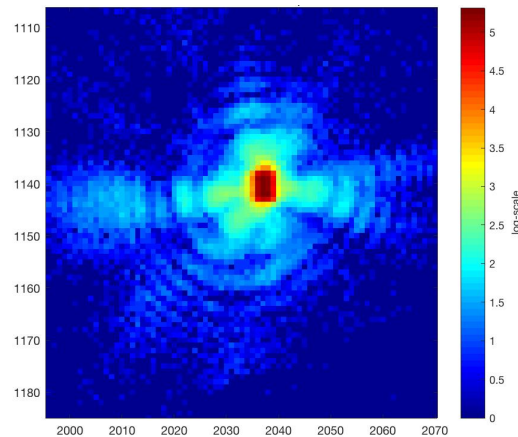
# Effect of the pinholes

Beam FWHM:  $3.1\mu\text{m}(\text{H}), 1.8\mu\text{m}(\text{V})$   
 $6\sigma$  width.  $7.9\mu\text{m}(\text{H}), 4.6\mu\text{m}(\text{V})$

Knife edge scan  
 $8.6\mu\text{m}$  pinhole  
Detector-sample  $\sim 40\text{cm}$



8.6/9.2 $\mu\text{m}$  pinhole



4.1/4.2 $\mu\text{m}$  pinhole

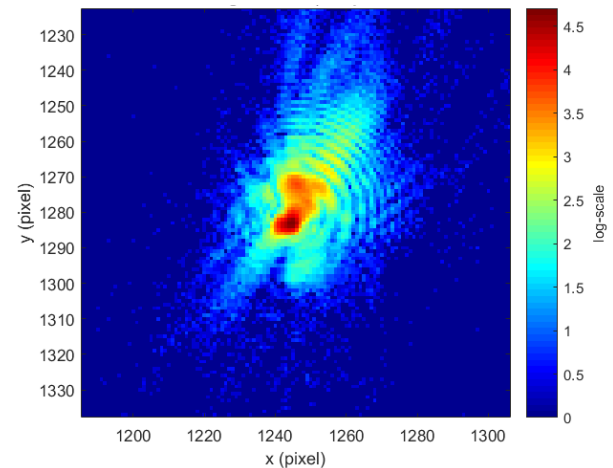
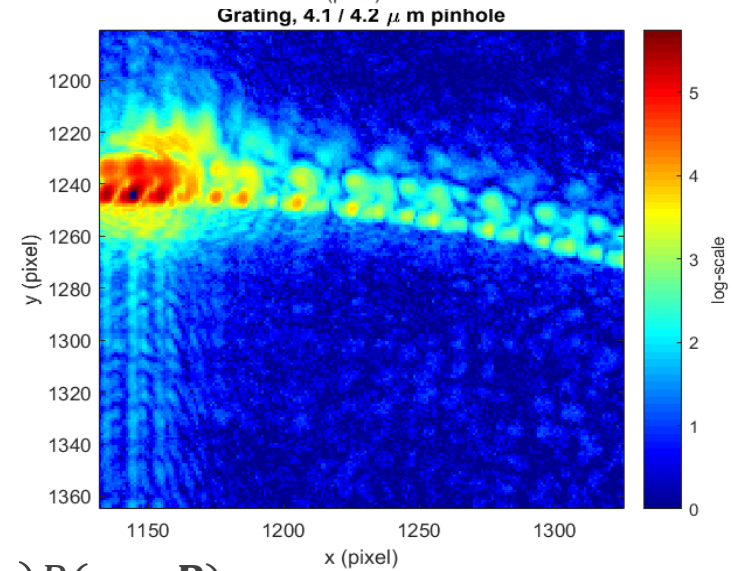
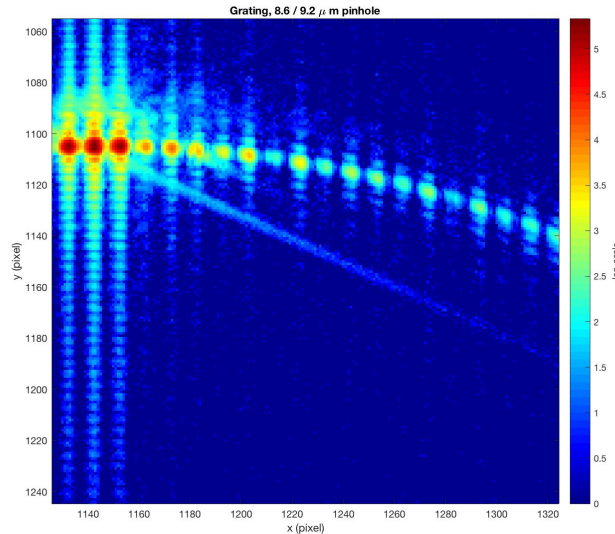
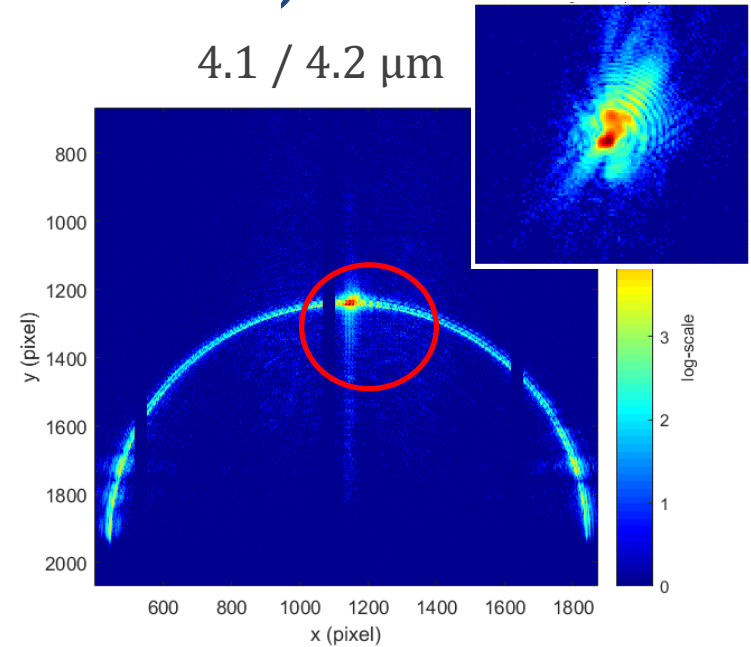
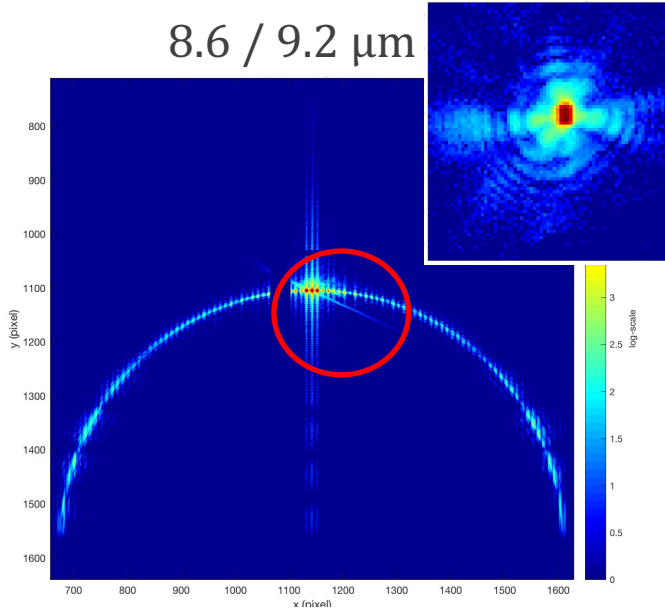


Image of the beam  
Detector-sample  $\sim 5.0\text{m}$

# Test with gratings (gold stripes on silicon)

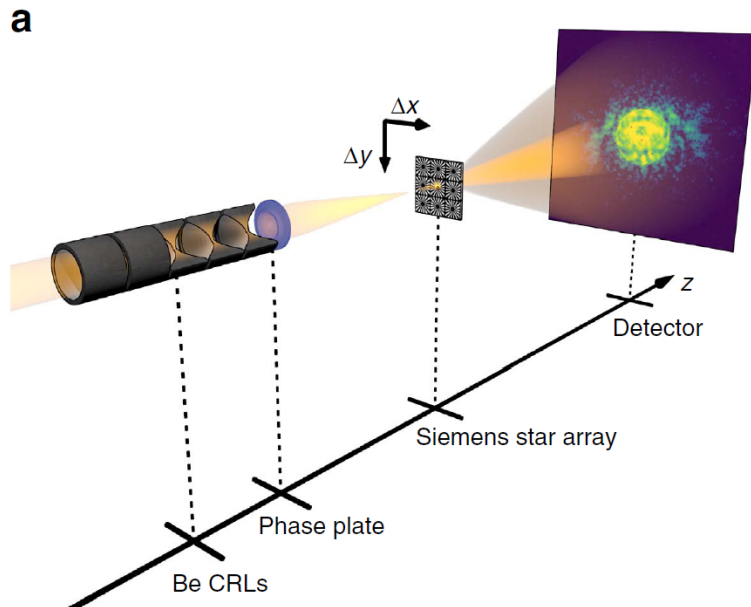
$Energy = 8keV$   
 $\alpha_i = 0.400^\circ$   
 $\alpha_c[Au] = 0.406^\circ$   
 $\alpha_c[Si] = 0.157^\circ$



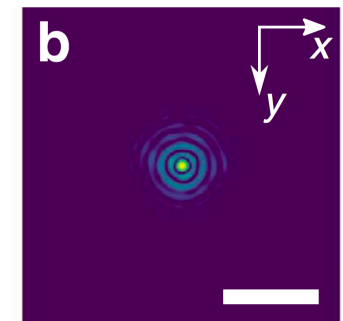
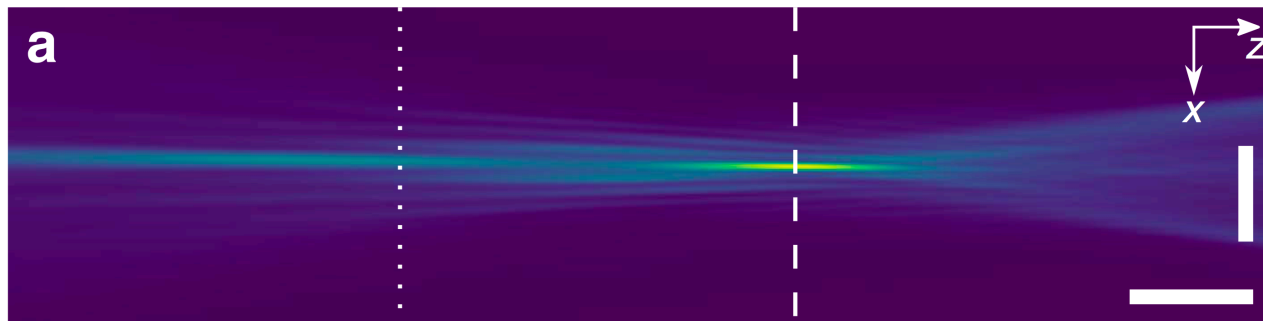
$$\psi(r, R) = O(r)P(r - R)$$



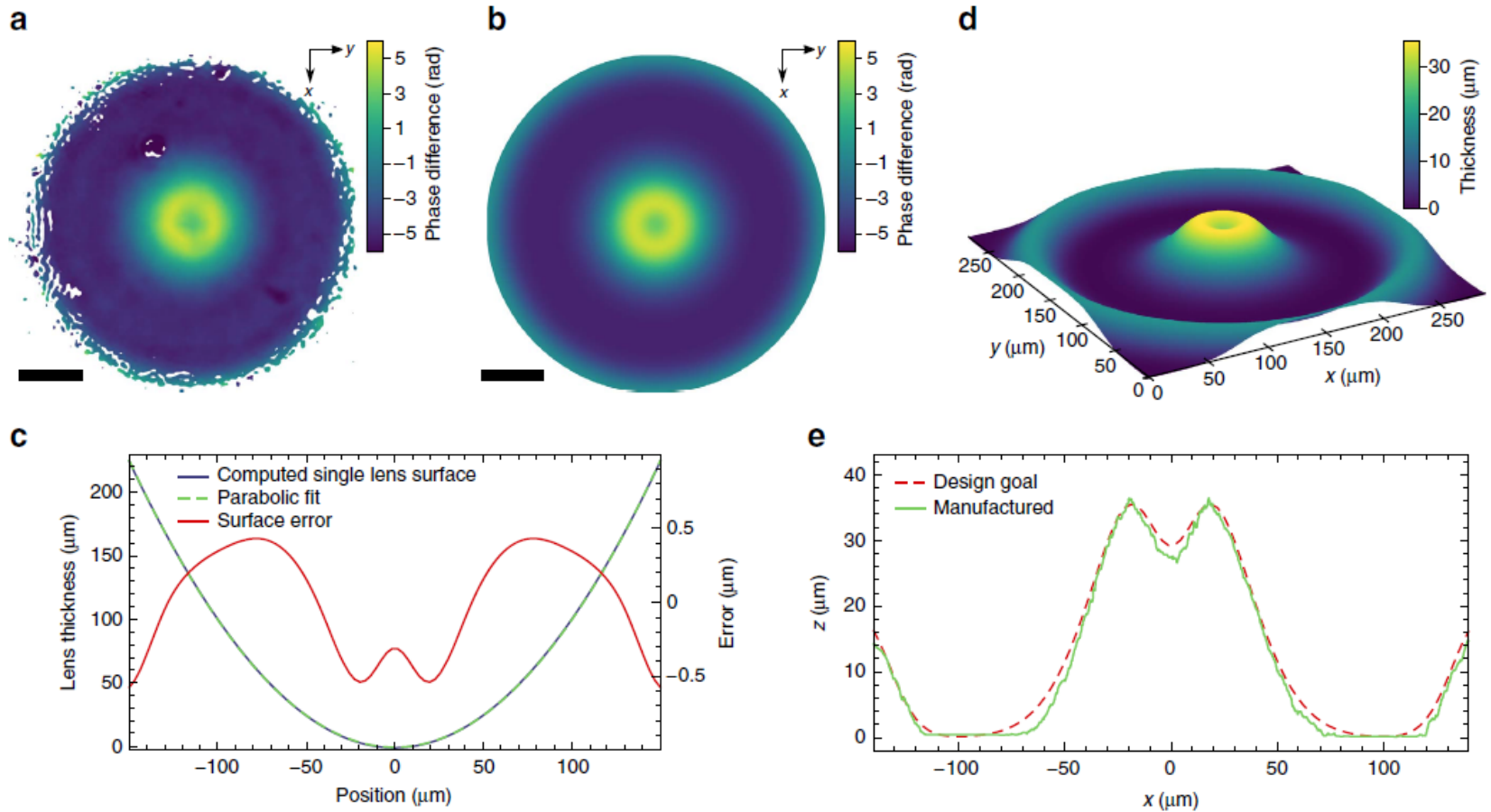
# Experimental setup



- Energy = 8.2 keV
- 20 sets of Be CRLs
  - $R = 50 \mu\text{m}$ ,  $D = 300 \mu\text{m}$
- Sample: **Standard Siemens stars** with 50 nm smallest features structured in 1 mm thick tungsten on a diamond substrate
- The sample and the wavefield were reconstructed with a ptychographic algorithm.
- Propagate the wavefield **back to the origin** with the Fresnel–Kirchhoff diffraction integral



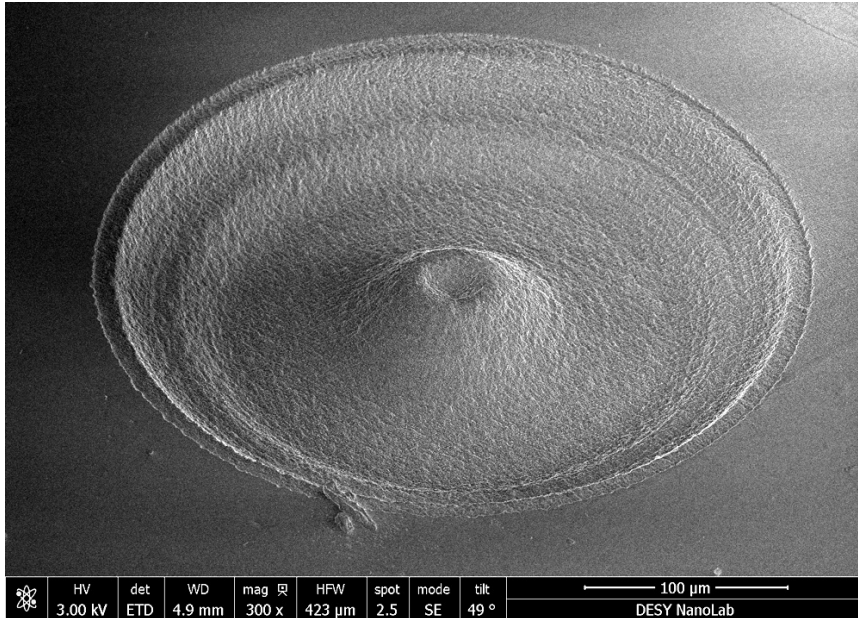
# The wavefield at CRLs exit



**Figure 2 | Initial lens characterization and phase plate design.** (a) Measured wavefront deformation at the lens exit compared to a spherical wave. (b) Phase error of a modelled lens stack at the lens exit. Scale bars in **a,b** correspond to 50  $\mu\text{m}$ . (c) Deformation of every lens surface in the modelled stack of 20 beryllium compound refractive lenses used to generate **b**. The surface error (solid red line) is enhanced by the axis on the right side. (d) Model of the  $\text{SiO}_2$  phase plate to correct for errors shown in **a-c**. (e) Surface profile of the manufactured corrective  $\text{SiO}_2$  phase plate using ultrashort-pulse laser ablation compared with the design goal **d** as measured by a laser scanning microscope.



# More about the phase plate



- ❑ Laser ablation (8ps @ 1030nm)
- ❑ Material: amorphous silicon oxide
  - Radiation hardness
  - Well know fabrication parameters
- ❑ X-ray transmission = 54% at 8.2keV
  - Can be increased to 95% if minimize the supporting SiO<sub>2</sub>

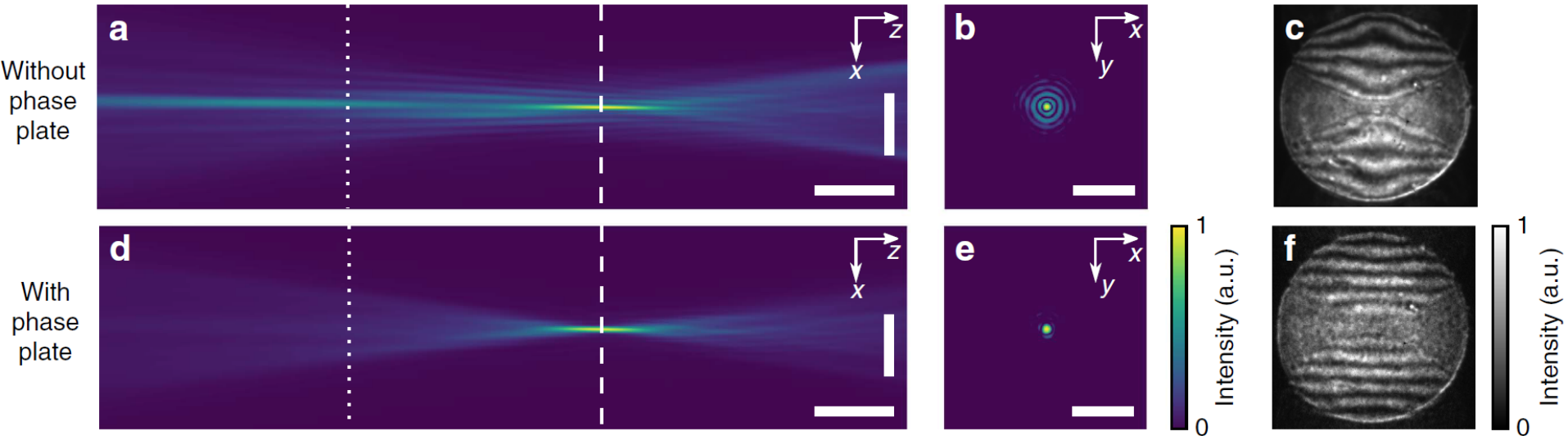
[http://photon-science.desy.de/news\\_events/news\\_highlights/scientists\\_develop\\_spectacles\\_for\\_x\\_ray\\_lasers/index\\_eng.html](http://photon-science.desy.de/news_events/news_highlights/scientists_develop_spectacles_for_x_ray_lasers/index_eng.html)



# Wavefield with/without phase plate

Without correction: 75% intensity in 800nm radius

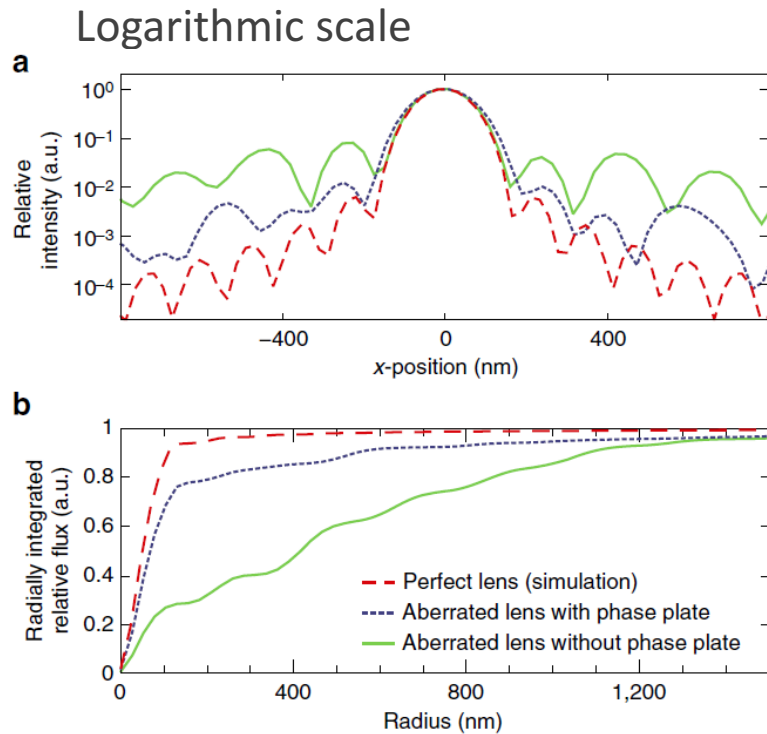
With correction : 75% intensity in 125nm radius



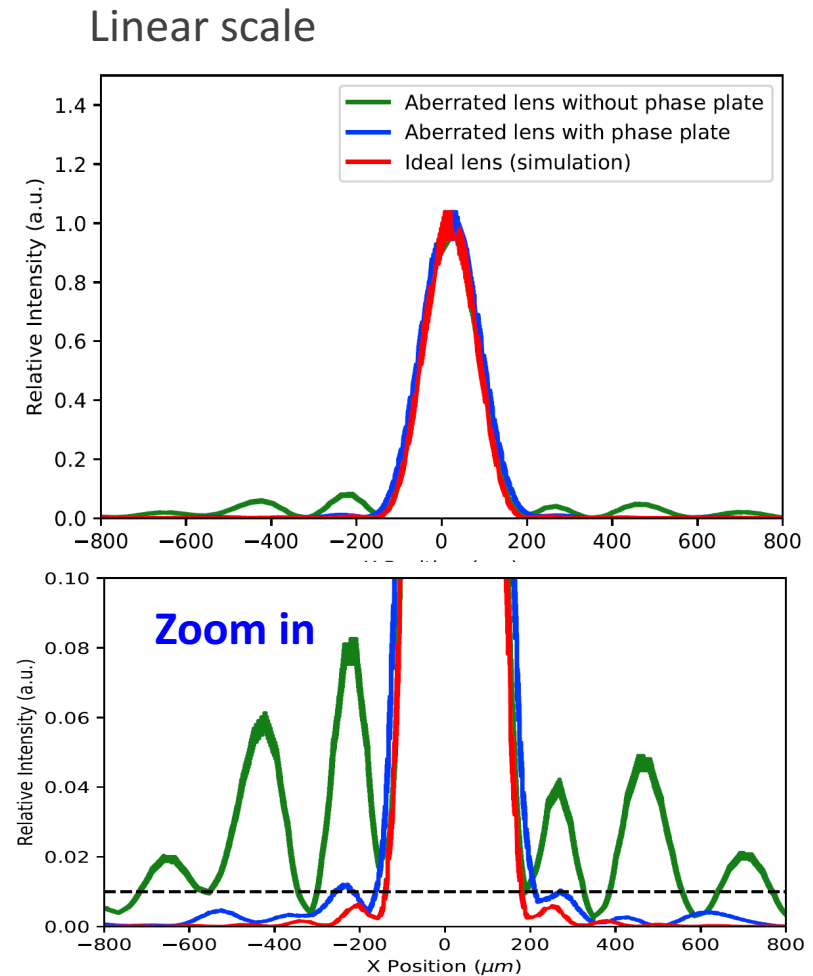
**Figure 3 | Aberration correction by a corrective phase plate.** (a) Beam caustic retrieved from the ptychographic reconstruction. Scale bars are  $2\ \mu\text{m}$  and  $1\ \text{mm}$  in  $x$  and  $z$  direction, respectively. (b) Logarithmic intensity distribution in the focal plane as marked by the dashed line in a. Scale bar represents  $2\ \mu\text{m}$  in  $x$  and  $y$  direction. (c) Ronchigram recorded at the dotted position in the beam caustic a. Insets a-c are without the phase plate. (d) Beam caustic retrieved from the ptychographic reconstruction. Scale bars identical to a. (e) Logarithmic intensity distribution in the focal plane as marked by the dashed line in d. Scale bar identical to b. (f) Ronchigram recorded at the dotted position in the beam caustic d. Insets d-f are with the phase plate installed. Insets a,b,d,e share the same colour bar as well as c,f.

Seiboth, Frank, et al. "Perfect X-ray focusing via fitting corrective glasses to aberrated optics." *Nature Communications* 8 (2017): 14623.

# Focal spot characteristics



**Figure 4 | Improved focal spot characteristics.** (a) Horizontal slice ( $x$ -direction, logarithmic scale) through the focal plane depicted in Fig. 3b,e and for an ideal lens. (b) Radially integrated intensity distribution around the centre of the focal spot. The solid green line represents the results for the uncorrected lens (without the phase plate), the dotted blue line represents the phase plate corrected lens, and the dashed red line represents the modelled aberration-free lens in both **a,b**.



Seiboth, Frank, et al. "Perfect X-ray focusing via fitting corrective glasses to aberrated optics." *Nature Communications* 8 (2017): 14623.

# Features

- In theory, this method also works for other focusing systems
  - KB, FZP, crystals/multilayers etc.
- Manufacturing challenges
  - Size  $\sim 10\text{-}100\mu\text{m}$ , tolerance  $\sim 0.1\mu\text{m}$  ?
  - 3D printing/laser/nanofabrication
  - Materials
    - Silicon oxide / metals / resists

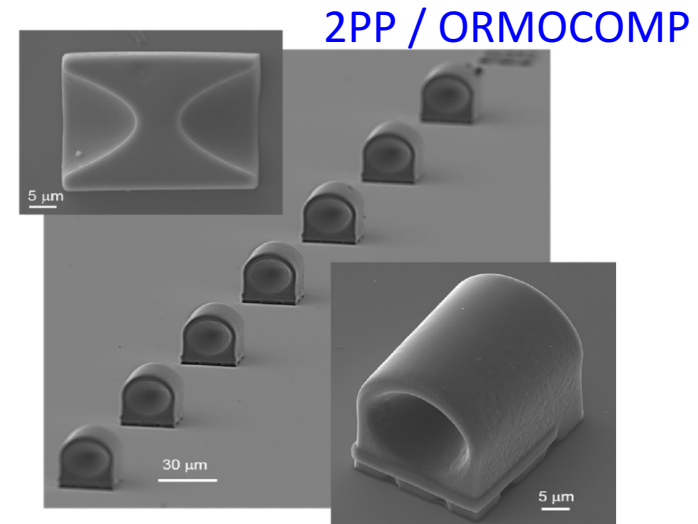


Fig. 2. SEM image of the fabricated polymer compound refractive lens. Upper insert shows the polymer lens in the cross-section. The insert in the bottom depicts individual refractive lens.

- The phase plate works over a large energy range.
  - Refractive index is almost material independent far from absorption edge
  - (But CRLs have strong chromatic aberration!)

Petrov, A. K., et al. "Polymer X-ray refractive nano-lenses fabricated by additive technology." *Optics Express* 25.13 (2017): 14173-14181.